



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hidekazu KOBAYASHI

Group Art Unit: 2871

Application No.:

10/722,448

Examiner:

Filed: November 28, 2003

Docket No.: 117830

For:

ELECTROLUMINESCENT DISPLAY DEVICE, METHOD FOR MANUFACTURING

THE SAME, AND ELECTRONIC EQUIPMENT

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 冈 This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- \boxtimes In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.
- 冈 English language Abstracts of the non-English language references are attached hereto.

Respectfully submitted,

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Date: October 24, 2005

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DEPOSIT ACCOUNT USE **AUTHORIZATION**

Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461 OCT 2 4 2005 WHAT

Sheet 1 of 1	
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Form PTO-1449 (REV. 8-83)		PATENT & TRADEMARK OFFICE	e E	ATTY DO	OCKET NO.		APPLICATION NO. 10/722,448			
INFORMATION DISCLOSURE STATEMENT										
(Use several sheets if necessary)			APPLICANT Hidekazu KOBAYASHI							
				FILING I	DATE er 28, 2003		GROUP 2871			
		U.S.	PATI	ENT DOCU	MENTS					
EXAMINER INITIAL		DOCUMENT NUMBER	1	DATE	NAM	IAME		CLASS	SUB CLASS	
	1	2002/0043934 A1	04/1	18/2002 Taizou TANAKA						
						<u>.</u>				
		FOREIC	GN PA	ATENT DO	CUMENTS					
		DOCUMENT NUMBER	1	DATE	COUNT	COUNTRY		CLASS	SUB CLASS	
	2	KR2002-0030726A (Corresponding to U.S. 2002/0043934 A1 and JP A 2002-198187)	04/25/2002		Korea					
	3	JP A 2002-198187 (w/Eng Abstr)	07/	12/2002	Japan					
					,					
	,	OTHER DOCUMENTS (Inc	cludin	ng Author,	Title, Date, Pertinent Page	es, etc.)	-	- -		
	4	Ching-Ting LEE et al., "Effects of Plasma Treatment on the Electrical and Optical Properties of Indium Tin Oxide								
	Fabricated by R.F. Reactive Sputtering", THIN SOLID FILMS, Vol. 386, 2001, pages 105-110									
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EXAMINER						DATE CONSIDERED				
		f citation considered, whether or not clance and not considered. Include copy of					line th	rough citati	on if not in	

Date: October 24, 2005